



#12  
9-16-03  
JPT

00862.022217

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Akihiro NAKAUCHI et al. ) Examiner: A. Mathews  
Application No.: 09/845,297 ) Group Art Unit: 2851  
Filed: May 1, 2001 )  
For: PROJECTION EXPOSURE )  
APPARATUS HAVING ABERRATION :  
MEASUREMENT DEVICE )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Further to the Information Disclosure Statement filed on October 15, 2001, in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

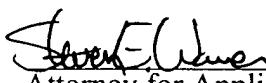
The Examiner's attention is also directed to co-pending U.S. patent application number 10/028,462, filed on December 28, 2001. A copy of this application is also enclosed. The art cited in this paper has been cited, to date, in this related application.

We also enclose a check for the required fee of \$180.00 to cover the Information Disclosure Statement under 37 C.F.R. 1.97(c)(2). The Commissioner is authorized to charge Deposit Account No. 06-1205 should any other fees be deemed necessary in connection with this paper.

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be initialed and returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
\_\_\_\_\_  
Attorney for Applicants  
Steven E. Warner  
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200

SEW/eab